



Attorney Docket No.: AMD-E365

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: YANG

Application No.: 09/805,273

Group No.: 2823

Filed: 03/13/2001

Examiner: ESTRADA, Michelle

For: HIGHLY CONDUCTIVE SEMICONDUCTOR STRUCTURES, METHOD OF FORMING SAME VIA PLASMA ETCH, AND ELECTRICAL DEVICES INCORPORATING HIGHLY CONDUCTIVE SEMICODUCTOR STRUCTURES

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**TRANSMITTAL OF NOTICE OF APPEAL**

1. Transmitted Herewith, In Triplicate, Is A Notice Of Appeal
2. STATUS OF APPLICANT  
This application is on behalf of  
[ X ] other than a small entity  
[ ] a small entity  
A verified statement:  
[ ] is attached  
[ ] was already filed
3. FEE FOR FILING NOTICE OF APPEAL  
Pursuant to 37 C.F.R 1.17(f), the fee for filing the Notice of Appeal is:  
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**CERTIFICATE OF MAILING/TRANSMISSION (37 CFR 1.8A)**

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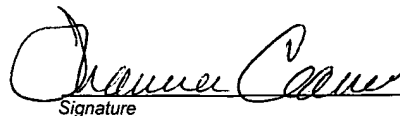
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